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TRANSMITTAL OF INFORMATION DISCI (Under 37 CFR 1.97(b) or 1.	Docket No. BUR92000077US1						
In Re Application Of: Jack O. C. u et al. FEB 0 1 2002							
Serial No.	Examiner	Group Art Unit					
09/683,088 11/16/2001	Unknown	Unknown					
Title: SINGLE REACTOR, MULTI-PRESSURE CHEMICAL VAPOR DEPOSITION FOR SEMICOMDUCTOR							
	Address to: Assistant Commissioner for Patents Washington, D.C. 20231						
37	CFR 1.97(b)						
1. A The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.							
37	CFR 1.97(c)						
2. The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:							
☐ the statement specified in 37 CFR 1.97(e);							
OR							
☐ the fee set forth in 37 CFR 1.17(p).	¢.	ECENTED OF TOO					

3. 4,

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT Docket No. (Under 37 CFR 1.97(b) or 1.97(c)) BUR920000077US1 In Re Application: FEB 0 1 2002 Serial No. Filing Date Examiner **Group Art Unit** 09/683,088 11/16/2001 Unknown Unknown SINGLE REACTOR, MULTI-PRESSURE CHEMICAL VAPOR DEPOSITION FOR **Payment of Fee** (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) A check in the amount of is attached. The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 09-0456 as described below. A duplicate copy of this sheet is enclosed. Charge the amount of X Credit any overpayment. Charge any additional fee required. Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail certify that this document and authorization to charge deposit I certify that this document and fee is being deposited account is being facsimile transmitted to the United States with the U.S. Postal Service Patent and Trademark Office (F as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231. (Date) Signature Signature of Person Mailing Correspondence C. Mueller Typed or Printed Name of Person Signing Certificate Typed or Printed Name of Person Mailing Certificate *This certificate may only be used if paying by deposit account, Dated: 1/8/2002 Signature RECEIVED TOO Mark F. Chadurjian, Reg. No. 30,739 IP Law Department, Mail Drop 972E **IBM Corporation** 1000 River Street Essex Junction, VT 05452 Telephone: 802-7690-8843 CC:

FEB 0 1 2002 300	SURE STATEMENT (c))	Docket No. BUR920000077US1	
n Re Malication Com	Jack O. Chu et al.		
Serial No. 09/683,088	Filing Date 11/16/2001	Examiner Unknown	Group Art Uni Unknown
Title: SINGLE REACT	OR, MULTI-PRESSURE CHEMIO	CAL VAPOR DEPOSITION FO	OR SEMICOMDUCTOR
	Assistant Com	dress to: missioner for Patents ton, D.C. 20231	
	37 C	FR 1.97(b)	
of a national ap three months of application; befo	Disclosure Statement submitted oplication other than a continued the date of entry of the national ore the mailing of a first Office Act filing of a request for continued ex	prosecution application under stage as set forth in 37 CFR 1 tion on the merits, or before the	37 CFR 1.53(d); within 1.491 in an international e mailing of a first Office
	37 C	FR 1.97(c)	
CFR 1.97(b), pi Final Action un	Disclosure Statement submitted rovided that the Information Disclor 37 CFR 1.113, a Notice of sprosecution in the application, and	losure Statement is filed befor Allowance under 37 CFR 1.	e the mailing date of a
☐ the stater	ment specified in 37 CFR 1.97(e);		
	OR		
☐ the fee se	et forth in 37 CFR 1.17(p).		
			RECEIVED FEB 07 2002 TO 1700

PSMITTAL OF INFORMATION DISCLOSURE STATEMENT Docket No. FEB 0 1 2002 (Under 37 CFR 1.97(b) or 1.97(c)) BUR920000077US1 Jack O. Chu et al. Application **Group Art Unit** Examiner Serial No. Filing Date Unknown 11/16/2001 Unknown 09/683,088 SINGLE REACTOR, MULTI-PRESSURE CHEMICAL VAPOR DEPOSITION FOR **Payment of Fee** (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) is attached. A check in the amount of ☑ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 09-0456 as described below. A duplicate copy of this sheet is enclosed. Charge the amount of X Credit any overpayment. Charge any additional fee required. Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail certify that this document and authorization to charge deposit I certify that this document and fee is being deposited with the U.S. Postal Service account is being facsimile transmitted to the United States as first class mail under 37 C.F.R. 1.8 and is Patent and Trademark Office (F addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231. (Date) Signature of Person Mailing Correspondence Signature C. Mueller Typed or Printed Name of Person Mailing Certificate Typed or Printed Name of Person Signing Certificate *This certificate may only be used if paying by deposit account, Dated: 1/8/2002 Signature Mark F. Chadurjian, Reg. No. 30,739 IP Law Department, Mail Drop 972E RECEIVED
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TO 1700 **IBM Corporation** 1000 River Street Essex Junction, VT 05452 Telephone: 802-7690-8843 CC:

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In re Application of:

Jack Oon Chu et al.

Serial No.: To be assigned

Art Unit: To be assigned

Filed: Herewith

Examiner: To be assigned

For: SINGLE REACTOR, MULTI-

PRESSURE CHEMICAL VAPOR DEPOSITION FOR SEMICONDUCTOR DEVICES

Atty Docket: BUR920000077US1

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TO 1700

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

For insuring compliance with the applicant's duty of disclosure under 37 CFR § 1.56, the undersigned hereby submits the documents listed on the attached Form PTO-1449 for consideration by the Examiner in charge of the above-identified patent application.

The listing of these materials is not to be construed as an admission that such is actually prior art with respect to the invention of the present application and is not to be construed that such is material with respect to the present invention.

These documents are being submitted (check only one of the next four boxes):

[XXX] within three months of the filing of the above U.S. national application or of the date of entry of the U.S. national stage in an International Patent Application (no fee is due);

[] before receiving a first Office Action on the merits of the above-identified patent application (no fee is due);

[]		following receipt of a first Office Action, but before issuance of a Final Office Action or a Notice of Allowance (if this box is checked, one of the last three boxes also must be checked);
		<u>OR</u>
[]		following receipt of a Notice of Allowance or a Final Office Action (if this box is checked, the next box and one of the last three boxes also must be checked).
	[]	PETITION - The undersigned hereby requests consideration of this information after mailing the Final Office Action or Notice of Allowance by filing this Petition under 37 CFR § 1.97(d)(2)(ii) and attaching our check in the amount of \$180.00 as the petition fee set forth in 37 CFR § 1.17(i)(1).
[]		Our Check in the amount of \$180.00 is attached in payment of the fee set forth in 37 CFR § 1.17(p).
[]		The undersigned certifies that each item of this information is being submitted within three months of the date it was cited by a foreign patent office for the first time in a counterpart application.
[]		The undersigned certifies that, after making reasonable inquiry, he/she has no knowledge that any item of this information was cited by a foreign patent office in a counterpart application or was known more than three months prior to this submission.

The Director is hereby authorized to charge payment of any deficiency in the above fee(s) or to charge any additional fees required under 37 CFR § 1.16 or 1.17 or credit any overpayment to Deposit Account No. 22-0185. A duplicate copy of this authorization is attached for the Finance Branch.

Respectfully submitted,

Burton A. Amernick, Reg. No. 24,852

Connolly Bove Lodge & Hutz LLP

1990 M Street, N.W.

Washington, D.C. 20036-3425

Telephone: 202-331-7111

Date: 9-12-01

INFORMATION DISCLOSURE CITATION (Use several theets if necessary)				BUR920000077US1 Applicant(s) Jack O. Chu et al.				,	
		FEB 0 1 2002			Filing Date		Group Art Unit Ui	nknown	
An and a second			U.S. PAT	U.S. PATENT DOCUMENTS					
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	AA	5534713	7/9/96	Ismail, et al.				5/20/94	
	AB	5259918	11/9/93	Akbar, et al.				6/12/91	
	AC	6013134	1/11/00	Chu, et al.				1/18/98	
	AD	5298452	3/29/94	Meyerson				2/21/92	
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